

Form PTO-1449

Docker Number (Optional)

Application Number

TSMC-01-603

10/043, 863

Applicant

Chung Liang Cheng et al.

Filing Date

01/10/02

Group Art Unit

1765

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

(Use several sheets if necessary)

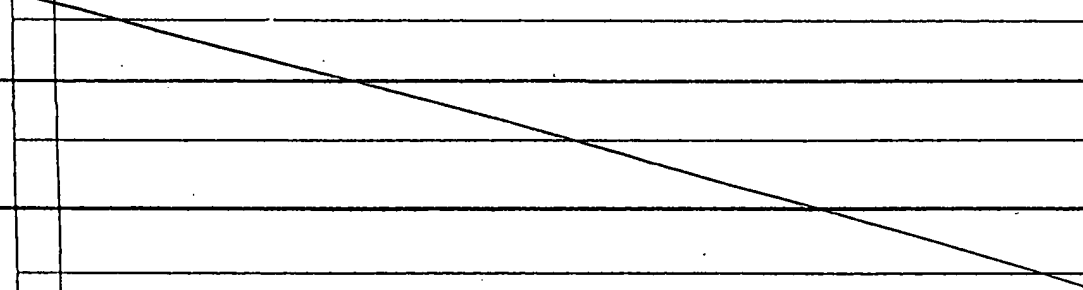
U. S. PATENT DOCUMENTS

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EXAMINER

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DATE CONSIDERED

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